	Application No.	Applicant(s)
Notice of Allowability	10/662,810	HAYAKAWA, YUKIO
	Examiner	Art Unit
	Tu-Tu Ho	2818
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in or other appropriate communing GHTS. This application is su	this application. If not included nication will be mailed in due course. THIS
1. X This communication is responsive to Papers filed 09/16/20	<u>03</u> .	
2. 🔀 The allowed claim(s) is/are <u>1-28</u> .		
3. $igspace$ The drawings filed on <u>16 September 2003</u> are accepted by	the Examiner.	
 4. Acknowledgment is made of a claim for foreign priority una) All b) Some* c) None of the: Certified copies of the priority documents have Certified copies of the priority documents have Copies of the certified copies of the priority documents have Topies of the certified copies of the priority documents have international Bureau (PCT Rule 17.2(a)). * Certified copies not received: 	been received. been received in Application	n No
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		a reply complying with the requirements
 A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give 		
 CORRECTED DRAWINGS (as "replacement sheets") must (a) ☐ including changes required by the Notice of Draftspers 1) ☐ hereto or 2) ☐ to Paper No./Mail Date (b) ☐ including changes required by the attached Examiner's Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1) 	on's Patent Drawing Review . s Amendment / Comment or	in the Office action of
each sheet. Replacement sheet(s) should be labeled as such in t	he header according to 37 CFF	R 1.121(d).
 DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT 	sit of BIOLOGICAL MATE FOR THE DEPOSIT OF BIO	RIAL must be submitted. Note the LOGICAL MATERIAL.
 Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☑ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/O Paper No./Mail Date 09/16/2003 	6. ☐ Interview Su Paper No./N	ormal Patent Application (PTO-152) Immary (PTO-413), Mail Date Amendment/Comment
Examiner's Comment Regarding Requirement for Deposit of Biological Material	9. Other David Nelms Supervisory Patent Examin	Statement of Reasons for Allowance - er
Technology Center 2800		

DETAILED ACTION

Allowable Subject Matter

1. Claims 1-28 are allowable over the prior art of record.

The following is an examiner's statement of reasons for allowance: The prior art of record fails to teach or render obvious a semiconductor device and a method of manufacturing thereof having all exclusive limitations as recited in claims 1 and 13, comprising a gate insulation layer and a gate electrode, the gate electrode comprising two polycrystalline silicon films of different crystal states, an upper surface of the upper polysilicon film being silicidized.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

- 2. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Copies of the references are not being furnished with this Office Action per MPEP § 707.05(a).
- U.S. Patent 5,903,053 to Lijima et al. discloses an amorphous alloy layer and a conductive layer on the amorphous layer. The amorphous layer is made of a matrix phase and microcrystal grains.

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3. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Tu-Tu Ho whose telephone number is (571) 272-1778. The

examiner can normally be reached on 6:30 am - 5:00 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, DAVID NELMS can be reached on (571) 272-1787. The fax phone numbers for the organization where this application or proceeding is assigned are (703) 872-9306 for regular communications and (703) 872-9306 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-1782.

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Tu-Tu Ho June 09, 2004 David Nelms
Supervisory Patent Examiner
Technology Center 2800

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